

FORM HDP-1449 (Based on Form PTO-1449)		ATTORNEY DOCKET NO.	SERIAL NO.		
PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION <small>(Use several sheets if necessary)</small>		9319S-000311/CPA		10/006,794	
		APPLICANT		Hitoshi FUKUSHIMA	
		FILING DATE		GROUP	
		December 4, 2001		2812	

U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.						

FOREIGN PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation * Yes	No
1.		10-217457A	08/18/1998	Japan			X
2.		99/038695	08/05/1999	WO			X
3.		11-15000	01/22/1999	Japan			X
4.		8-88402	04/02/1996	Japan			X

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
1.		H. Fukushima and 2 others, "Microstructure, Wettability, and Thermal Stability of Semifluorinated Self-Assembled Monolayers (SAMs) on Gold" J. Phys. Chem. B 2000, 104, pp. 7417-7423
2.		Notification of Reasons of Rejection dated June 8, 2005 in corresponding Japanese application No. JP2001-370544.

*One or more of the English translation documents submitted herewith may be Abstracts only or partial machine created translations from the Japanese Patent Office. As such, the submitter does not necessarily vouch for their accuracy. Additional information may be obtained from the Japanese Patent Office web site at www.jpo.go.jp.

Examiner:

Date Considered:

EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.